

Special Issue

Recent Developments of Optical MEMS and Photonics

Message from the Guest Editor

This Special Issue aims to highlight the recent developments and emerging trends in optical MEMS and photonics, encouraging the exchange of ideas and collaborations among the optical MEMS and photonics community. It is expected to appeal to researchers, engineers, and scientists working in the fields of optics, MEMS, Photonics, and related areas. Contributions are sought in the following areas but are not limited to:

- Design and modeling of optical MEMS and photonics;
- Fabrication techniques for optical MEMS and photonics;
- Integration of optical MEMS with other technologies;
- Characterization and testing of optical MEMS;
- Applications of optical MEMS in sensing, imaging, and communications;
- Novel optical MEMS devices and architectures;
- Novel frequency comb and the related applications

Guest Editor

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Deadline for manuscript submissions

closed (31 October 2023)



Micromachines

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Impact Factor 3.0
CiteScore 6.0
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Message from the Editor-in-Chief

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